



MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1773

PATENT
2185-0532P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: HIGASHI, Kenichi et al. Conf.: 7514
Appl. No.: 09/842,248 Group: 1773
Filed: April 26, 2001 Examiner: Nakarani, D.S.
For: LAMINATED FILM AND STRUCTURE COMPRISING
SAME

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 25, 2004

Sir:

In reply to the Office Action dated April 26, 2004, the due date for responding having been extended three months to October 26, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks.

OK to enter
ASN 11/01/04